



[10191/1690]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. Serial No. : 09/762,985
Title : DEVICE AND METHOD FOR
ETCHING A SUBSTRATE USING
AN INDUCTIVELY COUPLED PLASMA

Applicant(s) : Volker BECKER et al.

Filed : May 8, 2001

TC/A.U. : 1763

Examiner : Luz L. Alejandro Muller

Confirmation No. : 2674

Customer No. : 26646

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the
United States Postal Service with sufficient postage as first class mail
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AARON C. DEDITCH
(33,865)

**TRANSMITTAL AND PETITION
TO EXTEND PURSUANT TO 37 C.F.R. § 1.136(a)**

SIR:

Transmitted herewith for filing in the above-identified patent application is an
Amendment After A Final Office Action.

This is also a Petition pursuant to 37 C.F.R. § 1.136(a) to extend the three-month
response date to the Final Office Action mailed on September 19, 2005 by one month from
December 19, 2005 to January 19, 2006.

Please charge the appropriate fee, which is believed to be \$120.00, to Deposit
Account No. 11-0600. The Commissioner is also authorized to charge any additional fees
(including any extension fees) or credit any overpayment to Deposit Account No. 11-0600.
Two duplicate copies of this transmittal letter and petition are enclosed for that purpose.

Dated:

1/6/2006

Respectfully submitted,

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By:

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